



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 40296-0029

Applicant(s): Jung Taik Cheong et al

Confirmation No.: 8083

Appl. No.: 10/608,426

Examiner: Stephen W. Smoot

Filing Date: June 30, 2003

Art Unit: 2813

Title: METHOD FOR FORMING A SEMICONDUCTOR DEVICE WITH A
HARD MASK LAYER FORMED OVER A BIT LINE TO PROTECT
THE BIT LINE DURING SUBSEQUENT ETCHING STEPS

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents
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Sir:

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Respectfully submitted,

Date: 5/9/05

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